



1775

PATENT:

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLI-  
CATION OF

: O'Neill, et al

Docket: 06150 USA

SERIAL NO.

: 09/863,150

: GRP. ART UNIT:

FILED

: 05/23/2001

: EXAMINER:

#  
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FOR

: Low Dielectric Constant Material and Method of Processing By CVD

Assistant Commissioner for Patents  
Washington, D.C. 20231

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Sir:

**TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT  
WITHIN THREE MONTHS OF FILING OR  
BEFORE MAILING OF FIRST OFFICE ACTION (37 C.F.R. 1.97(b))**

The Information Disclosure Statement submitted herewith is being filed within three months of the filing date of the Application or date of entry into the national stage of an international application or before the mailing date of a first Office Action on the merits, whichever event occurs last. 37 C.F.R. 1.97(b). I do not believe there is a fee due, however, if the Examiner determines that a fee is due, then it is authorized to be charged to Deposit Account No. 01-0493.

Respectfully submitted,

Geoffrey L. Chase  
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